## PROCEEDINGS OF SPIE

# Integrated Optics: Devices, Materials, and Technologies XXII

Sonia M. García-Blanco Pavel Cheben Editors

29 January – 1 February 2018 San Francisco, California, United States

Sponsored and Published by SPIE

Volume 10535

Proceedings of SPIE 0277-786X, V. 10535

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Author(s), "Title of Paper," in Integrated Optics: Devices, Materials, and Technologies XXII, edited by Sonia M. García-Blanco, Pavel Cheben, Proceedings of SPIE Vol. 10535 (SPIE, Bellingham, WA, 2018) Seven-digit Article CID Number.

ISSN: 0277-786X ISSN: 1996-756X (electronic)

ISBN: 9781510615557 ISBN: 9781510615564 (electronic)

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Printed in the United States of America Vm7 i ffUb 5 ggc WJUh gz + Wzi bXYf WbgY Zfca GD-9.

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